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APPLICANTS

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\*\* CONTINUING DATA *yes TR* \*\*\*\*\*  
 This application is a DIV of 09/870,710 06/01/2001 PAT(6,720,661)

\*\* FOREIGN APPLICATIONS *yes TR* \*\*\*\*\*  
 JAPAN 2000-166104 06/02/2000  
 JAPAN 2000-338737 11/07/2000  
 JAPAN 2001-125581 04/24/2001

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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>Signature</i> Examiner's Signature	STATE OR COUNTRY JAPAN	SHEETS DRAWING 17	TOTAL CLAIMS 23	INDEPENDENT CLAIMS 1
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 25944  
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 22320

TITLE  
 Semiconductor device, method of fabricating the same, stack-type semiconductor device, circuit board and electronic instrument

<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing )
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